

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicant(s): Woody Tang, et. al  
Assignee: Mosel Vitelic, Inc.  
Title: Methods of Reducing or Removing Micromasking Residue Prior to Metal Etch Using Oxide Hardmask  
Application No.: 10/649,099 Filing Date: 08/26/2003  
Examiner: Dahimene, Mahmoud Group Art Unit: 1765  
Docket No.: M-12977-US Confirm: 4957

San Jose, California  
February 28, 2007

**M/S AMENDMENT**

**COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450**

**AMENDMENT**

Dear Sir:

In response to the Office Action having a mailing date of November 30, 2006 please amend the application as set forth below.

**Claims Listing** begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.

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